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In re Application of :
Mu-Liang Liao et al. :
Serial No. 10/707,838 : DECISION ON PETITION
Filed: January 16, 2004 : TO WITHDRAW AS ATTORNEY
For: ALL-IN-ONE POLISHING :
PROCESS FOR A SEMI- :
CONDUCTOR WAFER :
:

By papers filed on May 18, 2004, counsel has petitioned to withdraw as attorney of record in this application.

The petition is GRANTED.

Applicant is advised that the current correspondence address for this application is:

North American International Patent Office
P.O. Box 506
Merrifield, VA 22116

E. Rollins-Cross, Director
Technology Center 3700